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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Chang et al.

Attorney Docket No. 24061.65
2003-0230

Serial No.: 10/775,802

Customer No. 42717

Filed: February 10, 2004

Group Art Unit: 2125

**For: TANK SCHEDULING
OPTIMIZATION FOR REPLICATED
CHEMICAL IN A SEMICONDUCTOR
MANUFACTURING WET BENCH**

Examiner: M. Masinick
Confirmation No.: 9688

Commissioner for Patents
Mail Stop AF
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE AFTER FINAL OFFICE ACTION

Sir:

In response to the Final Office Action of September 16, 2005, please reconsider the application in light of the following amendments and remarks.

Amendments to the claims begin on page 2.

Remarks begin on page 4.